



# MS AMENDMENT

PATENT 0171-1022P

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Takeshi KINSHO et al. Conf.:

6775

Appl. No.:

10/671,732

Group:

1752

Filed:

September 29, 2003

Examiner: Sin J. LEE

For:

POLYMERIZABLE

SILICON-CONTAINING

COMPOUND,

MANUFACTURING METHOD, POLYMER, RESIST COMPOSITION

AND PATTERNING PROCESS

# LARGE ENTITY TRANSMITTAL FORM

#### MS AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 April 20, 2005

#### Sir:

Transmitted herewith is an amendment in the above-identified application.

The enclosed	d document	is	being	transm	itted	via	the	Certificate
of Mailing	provisions	of	37 C.	F.R. §	1.8.			

The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	17	-	20	=	0	\$50	\$0.00
INDEPENDENT	4	-	3	=	1	\$200	\$200.00
☐ FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM \$360 \$0.							\$0.00
						TOTAL	\$200.00

		month(s) extension of time pursuant to 1.136(a). \$0.00 for the extension of						
	No fee is required.							
$\boxtimes$	Check(s) in the amount of \$200.00 is(are) enclosed.							
	Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.							
overp requi	urrent, and future repli payment to Deposit Accour	ssioner is hereby authorized in this, les, to charge payment or credit any nt No. 02-2448 for any additional fees 1.16 or under 37 C.F.R. § 1.17; ime fees.						
		Respectfully submitted,						
		BIRCH, STEWART, KOLASCH & BIRCH, LLP						
		By Andrew D. Meikle, #32,868						
ADM/k	osh -1022P	P.O. Box 747 Falls Church, VA 22040-0747 (703) 205-8000						

Attachment(s)



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PATENT

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POLYMERIZABLE SILICON-CONTAINING COMPOUND,

MANUFACTURING METHOD, POLYMER, RESIST

COMPOSITION AND PATTERNING PROCESS

# REPLY UNDER 37 C.F.R. § 1.111

#### MS AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 20, 2005

### Sir:

In reply to the Office Action dated January 25, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes amendments to the claims and remarks.

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